

<b>INFORMATION DISCLOSURE STATEMENT</b>	Atty. Docket No.: P-7354	Serial No.: 09/017,195 U.S. PTO 525 09/199563 03/06/00
	<b>Applicant(s):</b> Markus Haller et al.	
<b>Filing Date:</b> February 2, 1998	<b>Group:</b> 3738	

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate
	AA	4,866,326	09/12/89	Niikawa et al.	310	315	02/17/88
	AB	4,895,500	01/23/90	Hök et al.	417	566	04/07/89
	AC	5,095,256	03/10/92	Ueyama et al.	318	116	11/29/89
	AD	5,096,388	03/17/92	Weinberg	417	322	03/22/90
	AE	5,147,141	09/15/92	Sakaida et al.	400	124	10/26/89
	AF	5,413,955	05/09/95	Lee et al.	437	86	12/21/93
	AG	5,129,794	07/14/92	Beatty	417	413	08/26/91
	AH	5,171,132	12/15/92	Miyazaki et al.	417	413	12/21/90
	AI	5,224,843	07/06/93	van Lintel	417	413 A	
	AJ	5,259,737	11/09/93	Kamisuki et al.	417	322	07/02/91
	AK	5,479,062	12/26/95	Yoshino	310	316	07/29/93

## FOREIGN PATENT DOCUMENTS

**OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)**

<i>10</i>		“Microflow devices and systems” - S. Shoji and M. Esashi (J. Micromech. Microeng. 4 (1994) pp 157-171)
<i>11</i>		“Piezo drive circuit performance” - C.M. Lopez (Medtronic)

<b>EXAMINER</b> 	<b>Date Considered</b> 12/12/03
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\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</b>	Atty. Docket No.: P-7354	Serial No.: 09/017,195
	Applicant(s): Markus Haller et al.	
	Filing Date: February 2, 1998	Group: 3738

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**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	SubClass	Translation
							Yes
AA	JP 6177449 A	06/24/94	Japan	H01L	41/09		X
AB	JP 5344755 A	12/24/93	Japan	H02N	02/00		X
AC	JP 5003683 A	01/08/93	Japan	H02N	02/00		X
AD	JP 4351200 A	12/04/92	Japan	H04R	17/10		X
AE	JP 4309273 A	10/30/92	Japan	H01L	41/09		X
AF	JP 2136245 A	05/24/90	Japan	B41U	02/30		X
AG	JP 2058280 A	02/27/90	Japan	H01L	41/09		X
AH	JP 6397854 A	04/28/88	Japan	F02D	41/20		X

**OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)**


**EXAMINER**

Date Considered

12/12/03

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